

**37th IUVSTA Workshop on the Plasma Deposition of Advanced Materials
September 15-18, 2003
Rolduc Conference Centre
Kerkrade, The Netherlands**

The 37th IUVSTA Workshop on the Plasma Deposition of Advanced Materials was held in Kerkrade, The Netherlands, at the Rolduc Conference Centre. The date of the workshop was September 15-18, 2003. This was truly an international meeting with 44 attendees representing thirteen different countries. We were all brought together by our common interest in understanding the role of the plasma in the growth of materials. With this interest in mind, we put together an exciting program with invited speakers from around the world who offered a wealth of knowledge, insight, and expertise. Workshop topics included basic growth mechanisms, surface interactions, and diagnostics, as well as deposition of polymers, nanotubes, silicon, carbon, high-k dielectrics, low-k dielectrics, and metals. The workshop was run in a Gordon-Conference style with sessions in the mornings and evenings. The afternoons were open to encourage free discussions. The local organizing committee was lead by Richard van de Sanden from Eindhoven University of Technology, who did a truly outstanding job. A Workshop Program can be found on the workshop website at www.ornl.gov/fed/pdam.